

Please replace the abstract with the following abstract:

ABSTRACT

~~The invention describes a~~ method for producing a piezoelectric component comprising at least two stacked crystal filters. ~~By means~~ comprises the steps of ~~the depositing~~ of the layer stack above the bottom electrode and the subsequent patterning of the upper electrically conductive layer and, if appropriate, second piezoelectric layer. Thus, it is possible, in a simple manner, with a minimum of process steps, to produce a piezoelectric component comprising two stacked crystal filters which are directly connected to one another via their bottom and central electrodes. The piezoelectric component ~~according to the invention~~ furthermore has the advantage that applications in which a high stop band attenuation is important can be realized with a relatively small number of filter stages. In this case, through the use of at least two stacked crystal filters, it is possible to achieve an excellent out-of-band rejection also for "single-ended signals".